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	Filing Date		2004-03-30
	First Named Inventor	Xiaole	ei Shi et al.
	Art Unit		1795
(Not for Submission under or of it 1.00)	Examiner Name	Anna	L. Verderame
	Attorney Docket Number	er	140264-1
	Art Unit Examiner Name	Anna	1795 L. Verderame

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	1		D. Krauss et al., "Femtosecond measurement of nonlinear absorption and refraction in CdS, ZnSe, and ZnS," merican Institute of Physics, Volume 65, No. 14, October 3, 1994.						
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